



PATENT  
Atty. Dkt. AMAT/3032.C6/DSM/LOW K/JW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:  
Cheung, et al.**

Serial No.: 10/648,616

Confirmation No.: 4378

Filed: August 26, 2003

## For: Plasma Processes For Depositing Low Dielectric Constant Films

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**CERTIFICATE OF MAILING**  
37 CFR 1.8

## **INFORMATION DISCLOSURE STATEMENT**

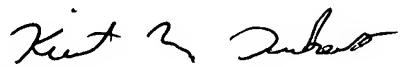
The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/3032.C6/DSM LOW K/JW	Serial No. 10/648,616
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		Applicant Cheung, et al.	Confirmation No. 4378
(Use several sheets if necessary)		Filing Date	Group
	Examiner Unknown	August 26, 2003	Unknown

NOV 10 2003  
PATENT & TRADEMARK OFFICE  
U.S. DEPARTMENT OF COMMERCE

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1	6,642,157	11/04/2003	Shioya, et al.	438	789	12/22/2000
	A2	6,596,655	07/22/2003	Cheung, et al.	438	789	09/19/2001
	A3	6,479,409	11/12/2002	Shioya, et al.	438	790	02/23/2001
	A4	6,340,628	01/22/2002	Van Cleemput, et al.	438	586	12/12/2000
	A5	6,331,494	12/18/2001	Olson, et al.	438	770	12/30/1999
	A6	6,153,537	11/28/2000	Bacchetta, et al.	438	763	12/22/1995
	A7	6,147,009	11/14/2000	Grill, et al.	438	780	06/29/1998
	A8	6,068,884	05/30/2000	Rose, et al.	427	255.6	04/28/1998
	A9	6,051,321	04/18/2000	Lee, et al.	428	447	10/24/1997
	A10	6,045,877	04/04/2000	Gleason, et al.	427	522	07/27/1998
	A11	5,989,998	11/23/1999	Sugahara, et al.	438	623	08/28/1997
	A12	5,554,570	09/10/1996	Maeda, et al.	437	235	01/09/1995
	A13	5,298,587	03/29/1994	Hu, et al.	528	10	12/21/1992

**Foreign Patent Documents**

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
	B1						<input type="checkbox"/>	<input type="checkbox"/>
	B2						<input type="checkbox"/>	<input type="checkbox"/>
	B3						<input type="checkbox"/>	<input type="checkbox"/>
	B4						<input type="checkbox"/>	<input type="checkbox"/>
	B5						<input type="checkbox"/>	<input type="checkbox"/>

**OTHER ART**

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
	C1	
	C2	

Examiner \_\_\_\_\_ Date Considered \_\_\_\_\_

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.